2813



PATENT
Atty. Dkt. No.: AMAT/5999/CMP/CMP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Moon, et al

Serial No.: 10/025,144

Confirmation No.: 5051

Filed: December 18, 2001

For: Method and Apparatus for Polishing

Metal and Dielectric Substrates

Commissioner for Patents P.O. Box 1450 Alexandria, VA. 22313-1450

Dear Sir:

Group Art Unit: 2813

Examiner: Stephen W. Smoot

CERTIFICATE OF MAILING 37 CFR 1.8

I hereby certify that this correspondence is being deposited on June 12., 2003, with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria VA, 22313-1450.

04/12/2003

Date

Signature

PROPOSED AMENDMENT TO THE DRAWINGS

Applicant proposes amendment of the drawings as described below and request permission to provide substitute drawings incorporating the amendments for reasons discussed below.

IN THE DRAWINGS.

Applicants propose amendment of the drawings to correct errors noted subsequent to filing the application. Applicants have submitted the proposed corrections marked in red on the attached copy of the respective original drawings filed in the application. The proposed corrections conform the drawings to the written

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